

Notice of References Cited

Application/Control No.

10/814,697

Applicant(s)/Patent Under
Reexamination
SHI ET AL.

Examiner

Anna L. Verderame

Art Unit

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Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-2004/0079195	04-2004	Perry et al.	075/345
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.